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**REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2113**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/669,931
Filed: September 24, 2003
Inventor(s):
Hans F. van Rietschote, Mahesh
P. Saptarshi, and Craig W. Hobbs

§ Examiner: Puente, Emerson C.
§ Group/Art Unit: 2113
§ Atty. Dkt. No: 5760-13900/VRTS
§ 0394

Title: Providing High Availability for an Application by Rapidly Provisioning a Node and Failing Over to the Node

**RESPONSE TO OFFICE ACTION OF
October 26, 2006**

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This paper is submitted in response to the Office Action of October 26, 2006, to further highlight why the application is in condition for allowance.

Please amend the case as listed below.